

<b>Notice of References Cited</b>	Application/Control No. 10/604,081	Applicant(s)/Patent Under Reexamination CHENG ET AL.	
	Examiner Jennifer M. Kennedy	Art Unit 2812	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,177,696	01-2001	Bronner et al.	257/301
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	C	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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**NON-PATENT DOCUMENTS**

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